



Attorney Docket No. 259/014

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Gu-Sung KIM, et al.

Examiner: Long Pham

Serial No. 10/073,173

Art Unit: 2822

Filed: February 13, 2002

For: WAFER LEVEL PACKAGE WITH AIR PADS AND MANUFACTURING
METHOD THEREOF

PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136

Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that an extension of time for the period indicated below be granted in accordance with the provisions of 37 C.F.R. §1.136 to take the action required in the application identified in caption, as reflected by the papers submitted herewith.

<u>X</u> First Month	\$110 (\$ 55)*
<u> </u> Second Month	\$290 (\$145)*
<u> </u> Third Month	\$520 (\$260)*
<u> </u> Fourth Month	\$520 (\$260)*
<u> </u> Fifth Month	\$500 (\$250)*

*(Small Entity) TOTAL FEE: \$110.00

The Commissioner is hereby authorized to charge the necessary extension fees to our Deposit Account No. 5-01645.

Respectfully submitted,

Eugene M. Lee
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December 16, 2002
Date

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